

Notice of References Cited	Application/Control No. 10/705,508	Applicant(s)/Patent Under Reexamination CHENG ET AL.	
	Examiner Adam C. Rehm	Art Unit 2875	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0150991	08-2004	Ouderkirk et al.	362/231
*	B	US-6,466,135	10-2002	Srivastava et al.	340/815.4
*	C	US-5,735,595	04-1998	Nederpel et al.	362/223
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NON-PATENT DOCUMENTS

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